Docket No.: 4684-030

JC10 Rec'd PCT/PTO 23 DEC 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| In re Application of | : : |
|----------------------------|-------------------|
| Kang-Ho AHN | : Confirmation No |
| U.S. Patent Application No | : Group Art Unit: |
| Filed herewith | : Examiner: |

For: APPARATUS FOR CONTROLLING FLOW RATE OF GASES USED IN SEMICONDUCTOR DEVICE BY DIFFERENTIAL PRESSURE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted

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ATTY. DOCKET NO. 4684-030 INFORMATION DISCLOSURE APPLICANT CITATION IN AN Kang-Ho AHN APPLICATION FILING DATE **GROUP** herewith (PTO-1449) U.S. PATENT DOCUMENTS **EXAMINER'S FILING CLASS SUBCLASS** PATENT NO. DATE NAME **INITIALS** DATE 11/28/2000 BALAZY et al 6 152 162 04/01/2003 6 539 968 B1 WHITE et al FOREIGN PATENT DOCUMENTS er a spirae 15 se **EXAMINER'S CLASS SUBCLASS** DATE COUNTRY PATENT NO. INITIALS 05/13/1991 JP abstract 3 111 914 JP 8 063 235 03/08/1996 abstract JP 8 152 346 06/11/1996 abstract OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.) **EXAMINER** DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.